

# MEASUREMENT OF THE ELECTRON TEMPERATURE IN A METALLIC COPPER USING ULTRAFAST LASER-INDUCED BREAKDOWN SPECTROSCOPY

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## Abstract

In this paper, we provide the laser-induced breakdown spectroscopic (LIBS) analysis of copper under the action of the ultrafast picosecond Nd:YAG laser and the specifications calculated from the electron temperature of plasma generated by the fundamental (1064 nm), second (532 nm), third (355 nm), and fourth (266 nm) laser harmonics. In this work, a laser pulse energy of  $60 \text{ mJ} \pm 5\%$  with a duration of 170 ps, a beam diameter of  $\sim 0.5 \pm 0.1 \text{ mm}$ , and a laser intensity  $1.79 \cdot 10^{11} \text{ W/cm}^2 \pm 8\%$  for a single shot was applied. The electron temperature is measured using three spectral lines of neutral copper (Cu I) at 515.3, 521.8, and 522.0 nm, according to the Boltzmann plot model where the local thermodynamic equilibrium (LTE) conditions were assumed. The electron temperature values observed are 13422, 15152, 16605, and 17783 K for laser wavelengths of 266, 355, 532, and 1064 nm, respectively. The experimental analysis reveals that the plasma electron temperature rises with the laser wavelength. Variations in the mass ablation rate, inverse Bremsstrahlung absorption, and photoionization with the laser wavelength variation allow us to explore the interaction dynamics. The results obtained allow for variation of the generated plasma electron temperature by guiding the picosecond pulse wavelengths; the later may allow for controlling plasma interactions, which can be applied in plasma spectroscopy of material science.

**Keywords:** ultrafast picosecond laser pulse, laser-induced breakdown spectroscopy (LIBS), copper plasma, electron temperature, Boltzmann plot, local thermodynamic equilibrium (LTE).

## 1. Introduction

A material breakdown can be generated by the plasma interaction, which created significant change in a matter temperature to overcome the binding electrostatic forces between its electrons and nuclei [1]. Subsequently, very hot gas is therefore collected of a mixture of neutral atoms, electrons, and ions [2]. Plasma breakdown spectroscopy is an important diagnostic method in plasma physics and technology. The plasma has two main categories, according to its temperature – the hot plasma with temperature  $T_p$  ranged from  $10^6 \text{ K}$  to  $10^8 \text{ K}$  and the cold plasma with temperature ranged from  $10^3 \text{ K}$  to  $10^4 \text{ K}$  [3].

Using a laser beam to induce material breakdown by focusing a high-energy laser pulse on any target material (solid, liquid or gas) is one of the essential plasma generation methods. The created radiation can lead to quick local heating, powerful evaporation, and degradation of the material at the focal point [4]. The interaction between the laser beam and the material depends on the mechanical, physical, and chemical features of the target, as well as on the properties of the laser [5].

Laser-induced breakdown irradiates emission spectra of various types, mostly extent from ultraviolet to visible and infrared regions. The technique based on the spectroscopic analysis of laser-produced breakdown optical emission is known as laser-induced breakdown spectroscopy (LIBS) [6]. The LIBS technique is suitable for fast on-line basic assessment of all material phases used to estimate the ratio target's impurity components with conventional calibration and empiric calibration-free methods [7].

Recently, ultrafast (ranged from picosecond to femtosecond) laser pulses became an interesting topic of research within laser pulse applications [8]. The studies of picosecond lasers include optical coherence tomography, new solutions for optical communications, and ultrashort laser pulse management. The ultrafast laser processing of materials provides various advantages over conventional procedures – a quick, accurate, and versatile technique, due to the electron–phonon interaction and quicker vaporization of the target material than the energy transfer to the surrounding areas [9]. For picosecond laser pulses, it has been previously shown that they are able to induce breakdown ablation with reduced heat-affected zone and less heat dissipation compared to nanosecond laser-pulse ablation [10].

Some scientists have studied the effect of the laser wavelength on the laser-induced breakdown spectroscopy parameters. In 2002, Abdellatif and Imam studied the laser-plasma parameters achieved by the nanosecond Nd:YAG laser at various laser wavelengths (1064, 532, and 355 nm) with different laser pulse energies (60, 100, and 500 mJ) for aluminum plates at different focusing lengths [11]. They determined that the maximum value of the electron temperature  $T_e$  was found at a certain distance away from the target surface depending on the laser wavelength, whereas the electron concentration  $N_e$  reaches its highest value near the target surface. In 2006, Fornarini et al. studied a range of fluxes 50–250 J/cm<sup>2</sup> of Nd:YAG laser with wavelengths of 1064 and 355 nm and with a pulse duration of 8 ns basing on the analytical outcomes acquired from the use of LIBS diagnostics of bronze plasma [12]. They inferred that more limited thermal effects are expected if a laser with a shorter wavelength is considered.

In 2015, Aberkane et al. determined the effect of 50 mJ Nd:YAG laser wavelengths 1064, 532, and 355 nm at 7, 9, and 10 ns pulse durations in the air at atmospheric pressure on the correlation between  $T_e$  and surface hardness of Fe–V–C metallic alloys [13]. They decided that the surface hardness measurement using LIBS is more efficient for the excitation laser with IR wavelength than with UV one. In 2019, the ultrafast femtosecond laser with a pulse wavelength of 800 nm, a pulse duration of 50 fs, and 1.9 mJ laser energy was used by Xu et al. to generate a high  $T_e$  and low  $N_e$  plasma with strong spectral intensity by changing the distance between the focusing lens and the sample surface in the LIBS configuration [14]. They found that the plasma with high  $T_e$  and low  $N_e$  can be used to improve the spectral resolution of LIBS.

In this work, we aim to apply a picosecond laser-induced breakdown spectroscopy to investigate the created copper-plasma spectrum. We study the LIBS spectra lines in the visible region and the effect of different laser wavelengths on the electron temperature in the plasma plume. We intentionally try to control a specific range of the plasma temperature by varying the wavelength of a picosecond laser pulse.

## 2. Methodology

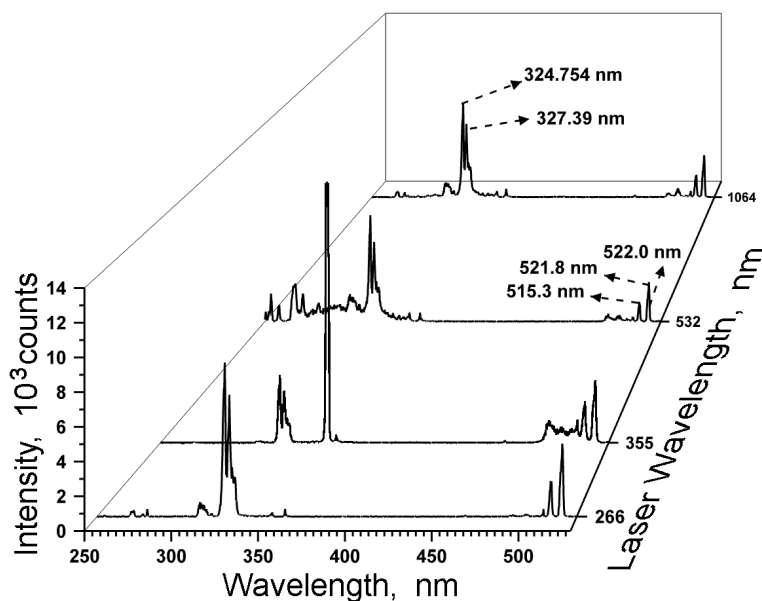
In the current experiment, the plasma was produced by focusing an ultrafast picosecond *Q*-switched Nd:YAG laser on a solid sample of a pure metal copper disk (K. J. Lasker Ltd., USA, a purity of 99.99%) with a thickness of 0.25 cm and a diameter of 3 cm. The experimental setup was shown and described previously [15], except the fact that the nanosecond ND:YAG laser is replaced by a 170 ps *Q*-switched Nd:YAG laser with four wavelengths: 1064, 532, 355, and 266 nm. This laser can deliver pulse energy of 60 mJ  $\pm$  5% at repetition rate of 1–5 Hz and laser intensity of  $1.79 \cdot 10^{11}$  W/cm<sup>2</sup>  $\pm$  8% under the atmospheric pressure. The laser pulse was monitored via a laser power meter (Model 11 Maestro, Standa LTD, Lithuania), then focused by a plane–convex quartz lens with a 150 mm focal length on the Cu disk target with a spot size of  $\sim 0.5 \pm 0.1$  mm to produce a plasma plume.

The copper target was placed on the *x–y* scanning stage to provide refreshing of the sample’s material surface for each laser pulse to minimize errors. A plane–convex quartz lens with a focal length of 100 mm was adjusted to the center of the plasma plume to collect the plasma emission at the 90° position to the laser axis. The collected emission was then transferred to an Ocean Optics spectrometer (HR4000 UV–NIR, 200–1100 nm) using an optical fiber with 400  $\mu$ m core diameter. The integration time was considered to be optimum at 10  $\mu$ s, and the delay time between the laser pulse *Q*-switch and the spectrometer detection was adapted to be 1  $\mu$ s, which was considered as an optimum to reach the LTE plasma as found before [16].

## 3. Result and Discussion

### 3.1. Studies of LIBS Spectrum

The qualitative compositional analysis of the Cu target is achieved from the optical emission spectrum of the laser-produced plasma created on the target surface using the ultrafast picosecond Nd:YAG pulsed



**Fig. 1.** LIBS emission spectra of Cu target generated by the laser pulse with an energy of 60 mJ at different laser wavelengths equal to 266, 355, 532, and 1064 nm.

laser.

Figure 1 represents the LIBS emission spectra of the Cu sample in the wavelength range 250–550 nm at different laser wavelengths  $L_\lambda$  equal to 266, 355, 532, and 1064 nm. All the spectra were recorded under identical experimental conditions. This spectral region is selected to exploit a transparency of the optically thin LTE plasma of the parameters found previously [17]. The three selected lines of singly-ionized copper are Cu I lines (515.320, 521.820, and 522.007 nm) due to the transitions ( $3d^{10}4d, 2D_{3/2} \rightarrow 3d^{10}4p, {}^2P_{1/2}$ ), ( $3d^{10}4d, 2D_{5/2} \rightarrow 3d^{10}4p, {}^2P_{3/2}$ ), and ( $3d^{10}4p, {}^2P_{3/2} \rightarrow 3d^{10}4d, {}^2D_{3/2}$ ), respectively. The characteristics and transitions of the selected Cu emission lines were identified with the help of the NIST database as shown in Table 1 with the data used to calculate the plasma electron temperature [18].

**Table 1.** Spectroscopic Parameters of the Emission Lines of CuI Used to Calculate the Plasma Parameters Taken from the NIST Database [18].

Wavelength of Cu I nm	Transitions		Transition probability $A_{ki}, 10^7 \text{ s}^{-1}$	Energies, eV			$g_k$
	Upper level	Lower level		$E_k$	$E_i$	$\Delta E$	
515.320	$3d^{10}4d, 2D_{3/2}$	$\rightarrow 3d^{10}4p, {}^2P_{1/2}$	6.00	6.191	3.785	2.406	4
521.820	$3d^{10}4d, 2D_{5/2}$	$\rightarrow 3d^{10}4p, {}^2P_{3/2}$	7.50	6.192	3.816	2.376	6
522.007	$3d^{10}4p, {}^2P_{3/2}$	$\rightarrow 3d^{10}4d, {}^2D_{3/2}$	1.50	6.191	3.816	2.375	4

### 3.2. Plasma Electron Temperature and LTE Considerations

Under the assumed local thermodynamic equilibrium (LTE) condition, where the emissions from electron collisions are much larger than that from the radiative processes [19], the plasma temperature can be calculated from the emission-line intensities of Cu, applying the Boltzmann plot method [16,20,21]; the result is

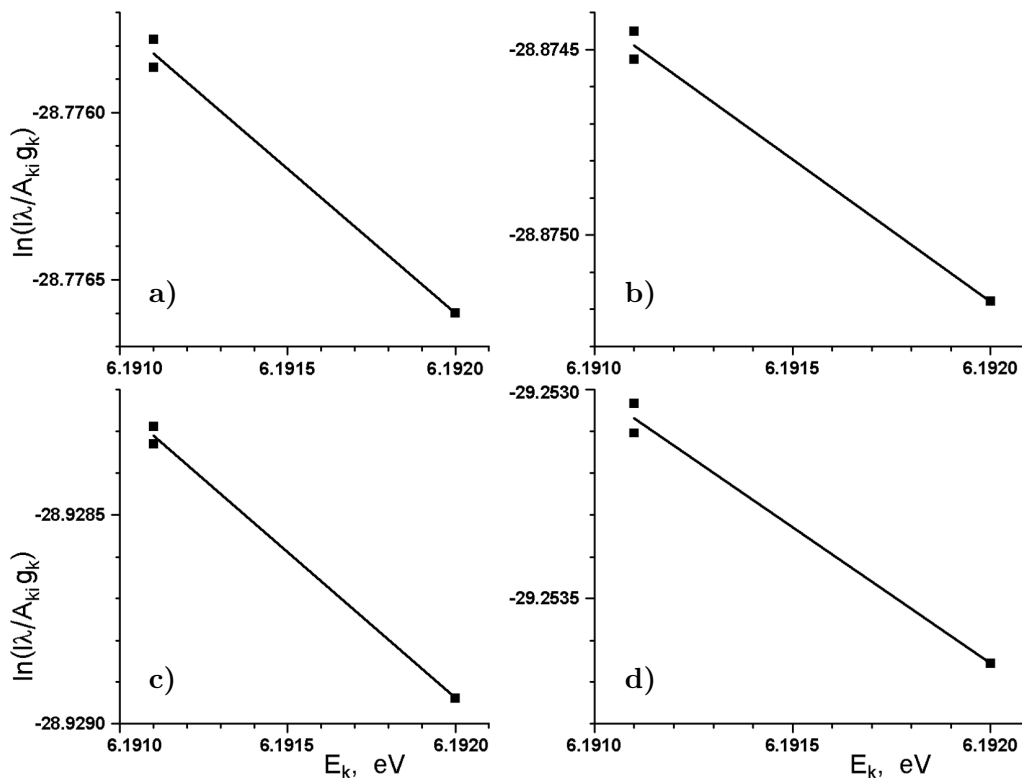
$$I = FC \frac{A_{ki}g_k}{\lambda U(T)} \exp\left(-\frac{E_k}{KT_e}\right); \quad (1)$$

the natural logarithm of Eq. (1) reads

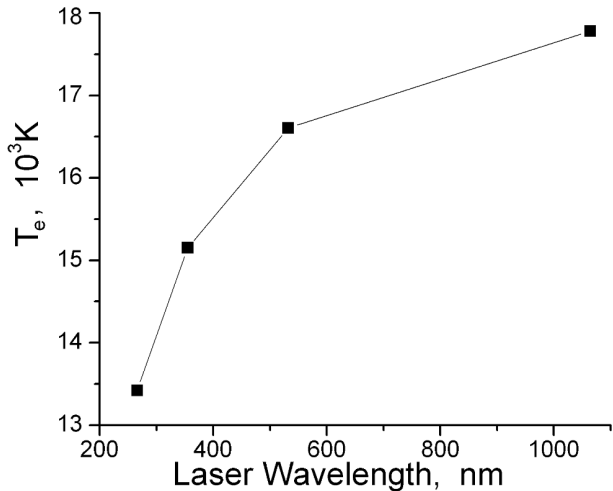
$$\ln \frac{I\lambda}{A_{ki}g_k} = -\frac{1}{KT_e}E_k + \ln \frac{FC}{U(T)}. \quad (2)$$

Here,  $I$  is the intensity of the spectral line,  $\lambda$  is the wavelength of the spectral line,  $K$  is the Boltzmann constant,  $U(T)$  is the partition function,  $A_{ki}$  is the transition probability,  $g_k$  is the statistical weight for the upper level,  $E_k$  is the excited-level energy,  $T_e$  is the electron temperature,  $F$  is an experimental factor, and  $C$  is the concentration of species.

The Boltzmann plots for CuI lines (515.32, 521.82, and 522.0 nm) at a laser pulse energy of 60 mJ are presented in Fig. 2, where the value  $\ln \frac{I\lambda}{A_{ki}g_k}$  is considered for each exciting energy  $E_k$  at different  $\lambda = 266, 355, 532,$  and  $1064$  nm. The electron temperature can be estimated from the slope provided by Eq. (2) with an uncertainty of about  $\pm 8\%$ , which mostly is related to the errors in measurements of the emission-line intensities and the transition probabilities [14, 17]. The observed data from the Boltzmann plots are summarized in Table 2 with a linear correlation coefficient  $R^2$  for each of the laser pulse energies.



**Fig. 2.** Boltzmann plots for the Cu I lines (515.32, 521.82, and 522.0 nm) at a laser pulse energy of 60 mJ and laser wavelengths 266 nm (a), 355 nm (b), 532 nm (c), and 1064 nm (d).



**Fig. 3.** The effect of different laser wavelengths and pulse energies on the Cu plasma temperature  $T_e$ .

**Table 2.** Data Analysis of the Boltzmann Plots and the Plasma Plume Temperature  $T_e$  at Different Laser Pulse Energies and Laser Wavelengths with Correlation Coefficient  $R^2$ .

Laser wavelength, nm	Slope	$T_e, K$	$R^2$
266	-0.8646	13422.3	0.992
355	-0.7659	15152.1	0.991
532	-0.6989	16604.6	0.996
1064	-0.6526	17782.7	0.989

From Table 2 we found that, at a laser pulse energy of 60 mJ, the plasma plume temperature ranges from around 13400 K to 17800 K depending on the laser wavelength.

Figure 3 demonstrates the dependence of the Cu plasma temperature on laser wavelengths at a laser pulse energy of 60 mJ. The plasma electron temperature increases with the laser wavelength, which is in

agreement with earlier studies [22,23]. This increase in the plasma temperature with the laser wavelength is related to plasma shielding [24, 25]. Due to the plasma shielding, once a plasma is generated, a part of the laser beam is absorbed by the plasma, by electron–ion inverse Bremsstrahlung or electron–neutral inverse Bremsstrahlung, and photoionization. The probability of electron–ion interaction is much higher than that of electron–neutral one, except at a very early stage of the laser evaporation process; according to this fact, electron–neutral inverse Bremsstrahlung is generally considered negligible during laser-induced plasma processes [23,24]. While, the inverse Bremsstrahlung absorption coefficient  $\alpha_{\text{IB}}$  and the photoionization absorption coefficient  $\alpha_{\text{PI}}$  are given in [26] as follows:

$$\alpha_{\text{IB}} = 1.37 \cdot 10^{-35} L_{\lambda}^3 N_e^2 T_e^{-1/2}, \quad (3)$$

$$\alpha_{\text{PI}} = 7.9 \cdot 10^{18} \left( \frac{L_{\lambda} E_n}{hc} \right)^3 \left( \frac{I}{E_n} \right)^{1/2} \sum_n N_{e_n}, \quad (4)$$

where  $L_{\lambda}$  is the laser wavelength in micrometers,  $T_e$  is the plasma electron temperature,  $E_n$  and  $N_{e_n}$  are the ionization energy and electron density of the excited state  $n$ , respectively,  $h$  is the Planck constant,  $c$  is the speed of light in vacuum, and  $I$  is the ionization potential of the atomic ground state.

The results obtained demonstrate that the plasma electron temperature is directly proportional to the laser wavelength  $L_{\lambda}$  at fixed laser pulse energy. This profile can be understood as follows: When laser interacts with the target surface, it creates plasma. The plasma near the focusing point is very hot and emits the Bremsstrahlung, known as the background emission.

Considering Eqs. (3) and (4), which depend on the laser wavelength, we can infer that the inverse Bremsstrahlung is the dominant interaction mechanism at 1064 nm (NIR), while the photoionization becomes the significant interaction mechanism at 266 nm (UV) [27,28]. Recently, Tan et al. have shown that for ultrafast picosecond laser pulse, the plasma shielding retains a great impact on the laser-induced plasma generation [10]. Increase in the laser wavelength from the UV to NIR leads to the increase in the target's surface temperature [29], which enhanced the number of free electrons. So, at 1064 nm (NIR), due to the inverse Bremsstrahlung, most of the laser energy is absorbed by free electrons of the target [10] that causes an increase in the electron temperature. These results are in agreement with the previous studies [10, 28, 30].

## 4. Conclusions

In this work, we studied the influence of the ultrafast picosecond laser wavelength at constant laser pulse energy on the generated copper-plasma plume parameters using the LIBS technique. We perceived that the plasma temperature displayed a strong dependence on the laser wavelength. We considered both the inverse Bremsstrahlung and photoionization absorption mechanisms for shielding of the copper surface and plasma. Increase in the picosecond-laser wavelength improves the plasma shielding due to the inverse Bremsstrahlung as the main absorption mechanism over the photoionization. So, most of the laser energy would be absorbed by free electrons of the target and preserves more energetic electrons, i.e., an increase in the electron temperature is connected with the increase in the picosecond laser wavelength. The obtained results revealed that the plasma temperature could be varied from 13400 K to 17800 K by altering the ultrafast laser wavelength. This result can be applied for plasma interaction dynamics, which is substantial for plasma spectroscopy of material science applications.

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